

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yukio SAKASHITA

Application No.: New U.S. National Stage of  
PCT/JP04/000265

Filed: July 21, 2005

Docket No.: 124796

For: THIN FILM CAPACITANCE ELEMENT COMPOSITION, HIGH PERMITTIVITY  
INSULATION FILM, THIN FILM CAPACITANCE ELEMENT, THIN FILM  
MULTILAYER CAPACITOR AND PRODUCTION METHOD OF THIN FILM  
CAPACITANCE ELEMENT

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**